SECRET Approved For Release 2005/05/20:1018-18DP78B04770A001400070016-4

	TALOG FORM	15 April 1969
1. PROJECT TITLE/CODE NAME	2. SHORT PROJECT DESCRIPTION	
Microdensitometer Modi- fications (Stage Modification)	This project is to fabrica the 1032T Microdensit	
3. CONTRACTOR NAME	4. LOCATION OF CO	ONTRACTOR
5. CLASS OF CONTRACTOR Manufacturer	6. TYPE OF CONTRACT	
7. FUNDS	8. REQUISITION NO.	9. BUDGET PROJECT NO.
FY 19 68 \$ None		
FY 19 69	10. EFFECTIVE CONTRACT DATE (Begin - end)	A.A Confidential T Unclassified
FY 19 70 \$ None	May 1969 - July 1969	W Unclassified
12. RESPONSIBLE DIRECTORATE/OFFICE/PR	OJECT OFFICER TELEPHONE EXTENSION	
DDI/NPIC/TSSG/DED		Declass Review by NGA.
Engineering Developm	ent	
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